

PATENT  
98095DIV4

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#2 | pre Amdt. A  
2.12.02 |  
Ratches

In re application of:  
Gonzalez et al

Group Art Unit:

SEMICONDUCTOR RAISED  
SOURCE-DRAIN STRUCTURE

Examiner:

Serial No.:

Filed:

PRELIMINARY AMENDMENT

November 9, 2001

Commissioner for Patents  
Washington, DC 20231

Sir:

Prior to examination and prior to calculation of the application filing fee, please amend the above-identified application as follows:

In the Specification

Page 1, line 1, please insert:

A  
~ CROSS REFERENCE TO RELATED APPLICATIONS

This is a divisional of copending United States patent application Serial No. 09/144,662,  
filed on September 1, 1998. ~

"Express Mail" mailing label number EM793310253US

Date of Deposit November 9, 2001

I hereby certify that this paper or fee is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 on the date indicated above and is addressed to the Commissioner of Patents, Washington, DC 20231

Patricia A. Mack